



03500.013630.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
MASAAKI IWANE ET AL. )  
Application No.: 09/346,678 )  
Filed: July 2, 1999 )  
For: CRYSTAL GROWTH PROCESS, )  
SEMICONDUCTOR DEVICE, )  
AND ITS PRODUCTION )  
PROCESS )  
July 23, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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AMENDMENT

Sir:

In response to the Office Action dated April 23, 2003, please amend the above-identified application as follows pursuant to 37 C.F.R. 1.116:

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on  
July 23, 2003.  
(Date of Deposit)

Justin D. Petruzzelli  
(Name)

  
Signature

July 23, 2003  
Date of Signature